

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hongqin Shi, et al.

Serial No.: 10/666,671

Filed: September 17, 2003

Title: METHODS AND APPARATUS OF ETCH PROCESS CONTROL IN
FABRICATIONS OF MICROSTRUCTURES

Grp./A.U.: 1765

Examiner: Lan Vinh

Confirmation No.: 8251

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450I hereby certify that this correspondence is being electronically filed
with United States Patent and trademark Office on:October 8, 2007 (Date)Debbie Sams

(Printed or typed name of person signing the certificate)

/Debbie Sams/

(Signature of the person signing the certificate)

Sir:

AMENDMENT UNDER 37 C.F.R. § 1.111

The Applicants have carefully considered this application in connection with the Examiner's Action electronically delivered July 6, 2007, and respectfully request reconsideration of this application in view of the following amendment and remarks.